

MELBOURNE CENTRE FOR NANOFABRICATION CUSTOMER CONTACT FORM

Please fill this form out as completely as possible. Incomplete forms may be returned for further details.

Name:	
Date:	
Email address:	
Phone number:	
Company/organisation/university:	
Supervisor's details (if applicable):	
 1. Which of the following is your primary appointment at the Academic staff Non-academic staff Research fellow/ Post Doc 	e organisation listed above? Postgraduate student Undergraduate student
2. Please give a short description of what you wish to accord Provide, where possible, process details and required instru-	

3. Do you wish to perform the work yourself or would you like to engage an MCN staff member to perform the work on your behalf?

Perform myself

Not sure yet

Engage MCN staff member (please skip questions 6-11)



4. Do you have a clear idea of the processes and tools you will require to complete your project? Yes

____ No

We are pleased to offer all clients a confidential consultation to assess how we can best meet your needs and to work with you to create a training plan. The first consultation up to one hour is free of charge and obligation free. Further design and/or fabrication process consulting is available at standard rates of \$60 per hour (academic clients) or \$120 per hour (Industry clients).

5. Do you have any particular time constraints or deadlines of which we should be aware?

6. Do you have any prior experience working in a cleanroom environment?

Yes
No

7. If yes, please describe where you gained this experience and the tools that you utilized and for how long you worked in this environment:

8. MCN offers a wide range of fabrication and characterisation tools and processes. To allow us to assist you more efficiently, please indicate which areas are most likely to be relevant to your project.

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Electron Beam Lithography	Laser Doppler Vibrometry
Focused Ion Beam Lithography	Profilometry
Photolithography	Laser Scanning Confocal Microscopy
Direct Write Lithography	Laser TIRF (Total internal reflection
Hot embossing/ Nano imprint lithography	fluorescence) microscopy
Atomic Layer Deposition thin films	Hyperspectral Imaging
Electroplating thin films	Microspectrometry
E-beam Evaporation thin films	Particle/zeta potential characterisation
Thermal Evaporation thin films	UV Vis spectroscopy
Sputtering thin films	Microarraying
Plasma Enhanced Chemical Vapour Deposition	Etching
thin films	Polymer/organic electronics tool suite.
Microwave Enhanced Diamond Deposition	3D polymer printing
Scanning Electron Microscopy	PC2 laboratory
Atomic Force Microscopy	PFQNM
Ellipsometry	Other (please specify over page)



8. Continued

 9. What area(s) does your project best fall under? Energy Biosensing Micro and Nanofluidics Nanomedicine and drug delivery 	 MEMS Optics Medical Bionics Other (please specify below)

10. Have you performed a review of the scientific literature? If so, please list the two to three most relevant publications in the space provided.

11. If there are any publications relevant to this project which you have authored/co-authored, please feel free to attach them with this form.

Please note: publications should aim to support your project description and not be provided in place of one.

Please submit this form to mcn-enquiries@nanomelbourne.com

A MCN staff member will respond to your request within two working days.